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| <b>INFORMATION DISCLOSURE<br/>STATEMENT BY APPLICANT</b><br>( Not for submission under 37 CFR 1.99) | Application Number   |                 | 10721117   |  |
|   | Filing Date          |                 | 2003-11-25 |  |
|   | First Named Inventor | Dominic Bennett |            |  |
|   | Art Unit             | 3688            |            |  |
|   | Examiner Name        | ALVAREZ, Raquel |            |  |
| Attorney Docket Number  |                      | 23YH-1067-01    |            |  |

### U.S.PATENTS

| Examiner Initial* | Cite No | Patent Number | Kind Code <sup>1</sup> | Issue Date | Name of Patentee or Applicant of cited Document | Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear |
|-------------------|---------|---------------|------------------------|------------|---|--|
| /R.A./            | 1       | 7111010       |                        | 2006-09-19 | Chen, Li-Wen                                    |  |
| /R.A./            | 2       | 7716173       |                        | 2010-05-11 | Stolte et al.                                   |  |

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| Examiner Signature | /Raquel Alvarez/ | Date Considered | 10/14/2010 |
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